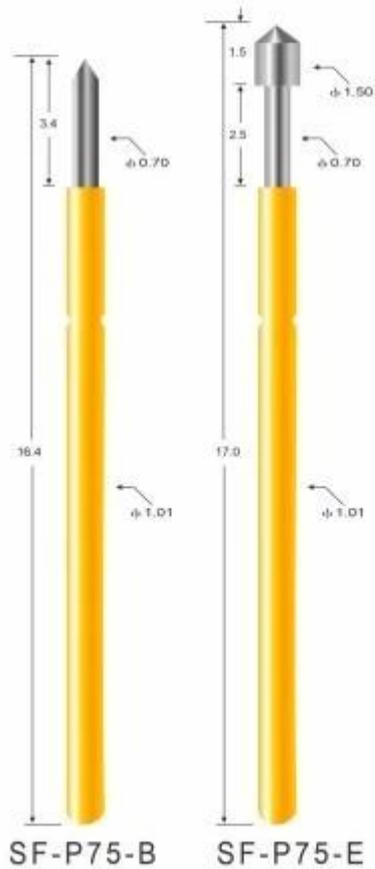
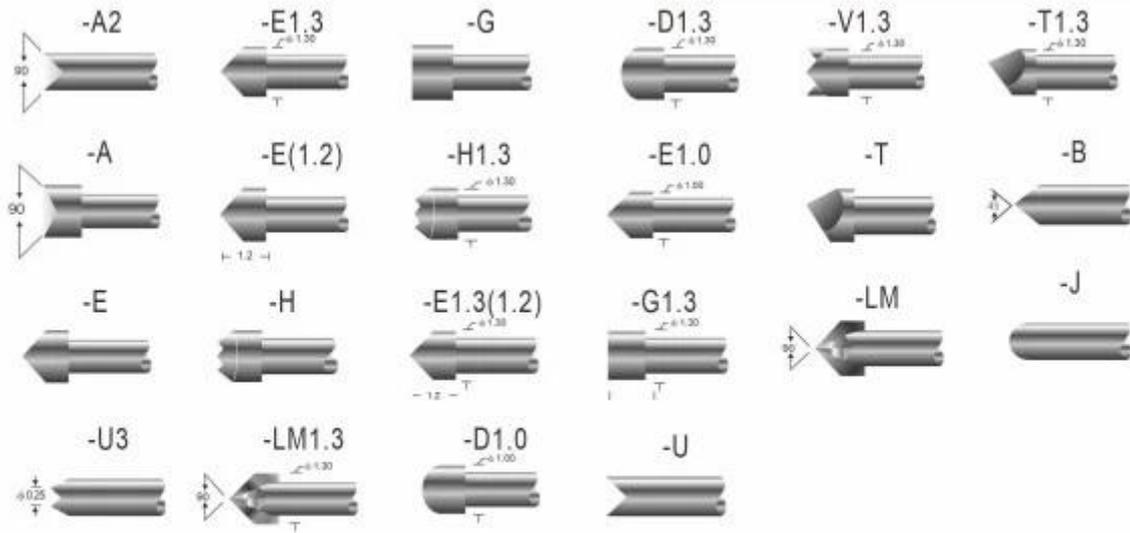


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### 技术规格 PROBE SPECIFICATIONS

Recommended minimum center 最小间距	1.90mm(.0748 ")
Mounting hole size 钻孔尺寸	压克力: 1.35mm(.0532 ") 电木板、玻璃纤维板: 1.40mm(.0551 ")
Full travel 行程	3.4(.1338 ") / 2.50(.0984 ")
Spring force 弹簧压力	120g(克)
Materials and finishes 材料及涂饰	Plunger: SK4, Ni or Au plated BeCu, Ni or Au plated Barrel: Phosphor bronze, Au plated Spring: Stainless steel
Current rating 额定电流	3A(安培)
Contact resistance 接触电阻	50mΩ(毫欧姆)

Receptacle specifications  
Materials and finishes: Phosphor bronze, Gold plated







1. Raw material warehouse



2. Lathe workshop



3. Assemble workshop



4. Quality inspection



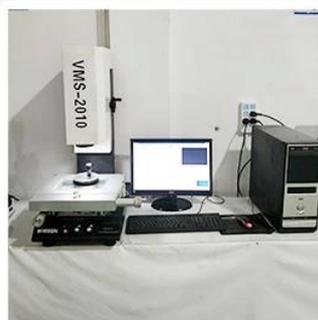
5. Finished products



6. Packing



1. Agilent current testing



2. Quadratic element



3. Load Curve Meter



4. Bond Test



5. Life Fatigue Test



6. Microscope







2023 ISO Certificate



Patent for Coaxial Structure



Patent for Honeycomb current probe











CIBF2021

苏州胜亿福睿电子科技有限公司  
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No.3B013

